



IOWA STATE UNIVERSITY
OF SCIENCE AND TECHNOLOGY



Tightly Coupled Mechanistic Study of Materials in the Extreme Space Environment

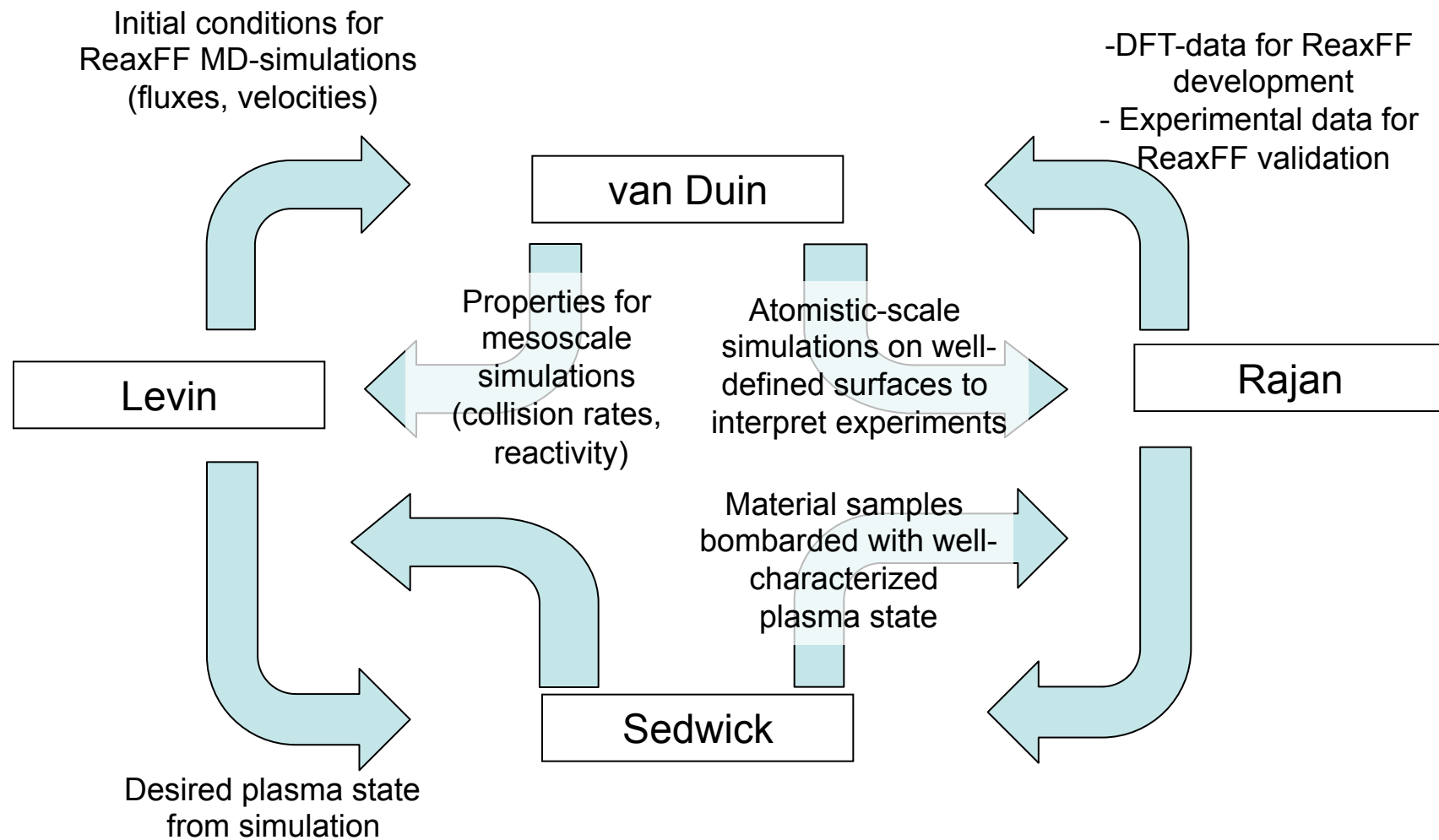
**2012 Space Propulsion and Power
Program Review**

10-14 September 2012, Arlington VA

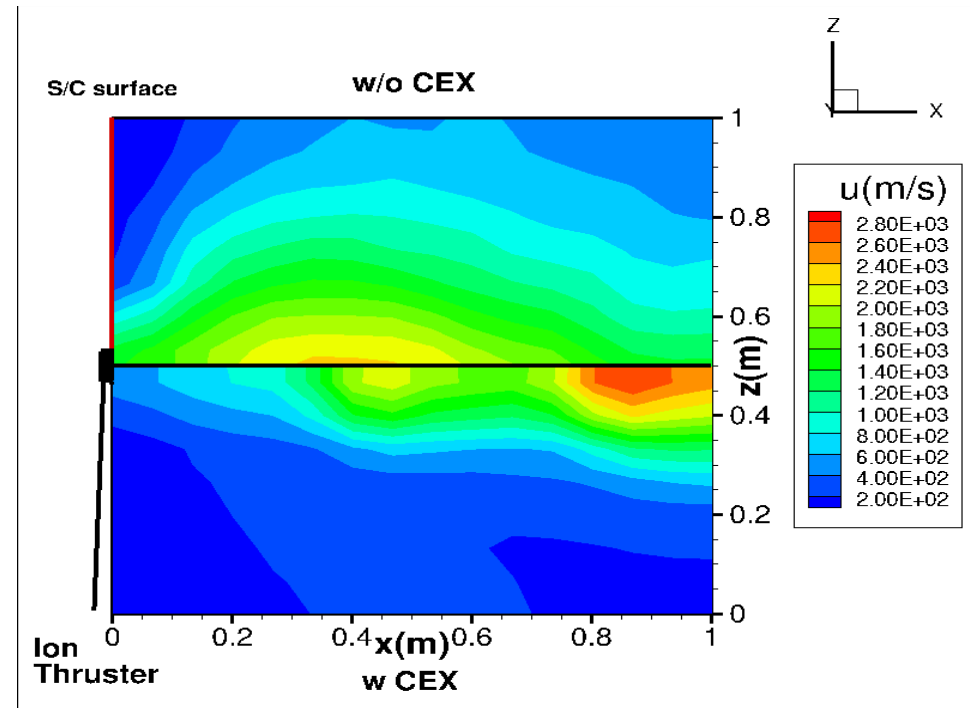
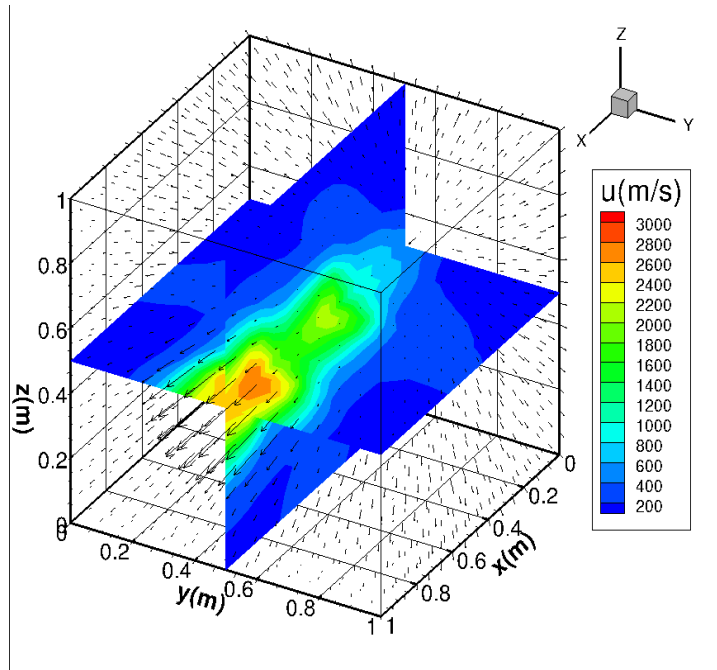
**Deborah A. Levin, Adri van Duin, Krishna Rajan,
Raymond Sedwick and Mark Lewis**

Report Documentation Page				Form Approved OMB No. 0704-0188	
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1. REPORT DATE SEP 2012		2. REPORT TYPE		3. DATES COVERED 00-00-2012 to 00-00-2012	
4. TITLE AND SUBTITLE Tightly Coupled Mechanistic Study of Materials in the Extreme Space Environment				5a. CONTRACT NUMBER	
				5b. GRANT NUMBER	
				5c. PROGRAM ELEMENT NUMBER	
6. AUTHOR(S)				5d. PROJECT NUMBER	
				5e. TASK NUMBER	
				5f. WORK UNIT NUMBER	
7. PERFORMING ORGANIZATION NAME(S) AND ADDRESS(ES) Penn State University,201 Old Main,University Park,PA,16802				8. PERFORMING ORGANIZATION REPORT NUMBER	
9. SPONSORING/MONITORING AGENCY NAME(S) AND ADDRESS(ES)				10. SPONSOR/MONITOR'S ACRONYM(S)	
				11. SPONSOR/MONITOR'S REPORT NUMBER(S)	
12. DISTRIBUTION/AVAILABILITY STATEMENT Approved for public release; distribution unlimited					
13. SUPPLEMENTARY NOTES Presented at the 2012 AFOSR Space Propulsion and Power Program Review held 10-13 September in Arlington, VA. U.S. Government or Federal Rights License					
14. ABSTRACT					
15. SUBJECT TERMS					
16. SECURITY CLASSIFICATION OF:			17. LIMITATION OF ABSTRACT Same as Report (SAR)	18. NUMBER OF PAGES 11	19a. NAME OF RESPONSIBLE PERSON
a. REPORT unclassified	b. ABSTRACT unclassified	c. THIS PAGE unclassified			

Connections in this project

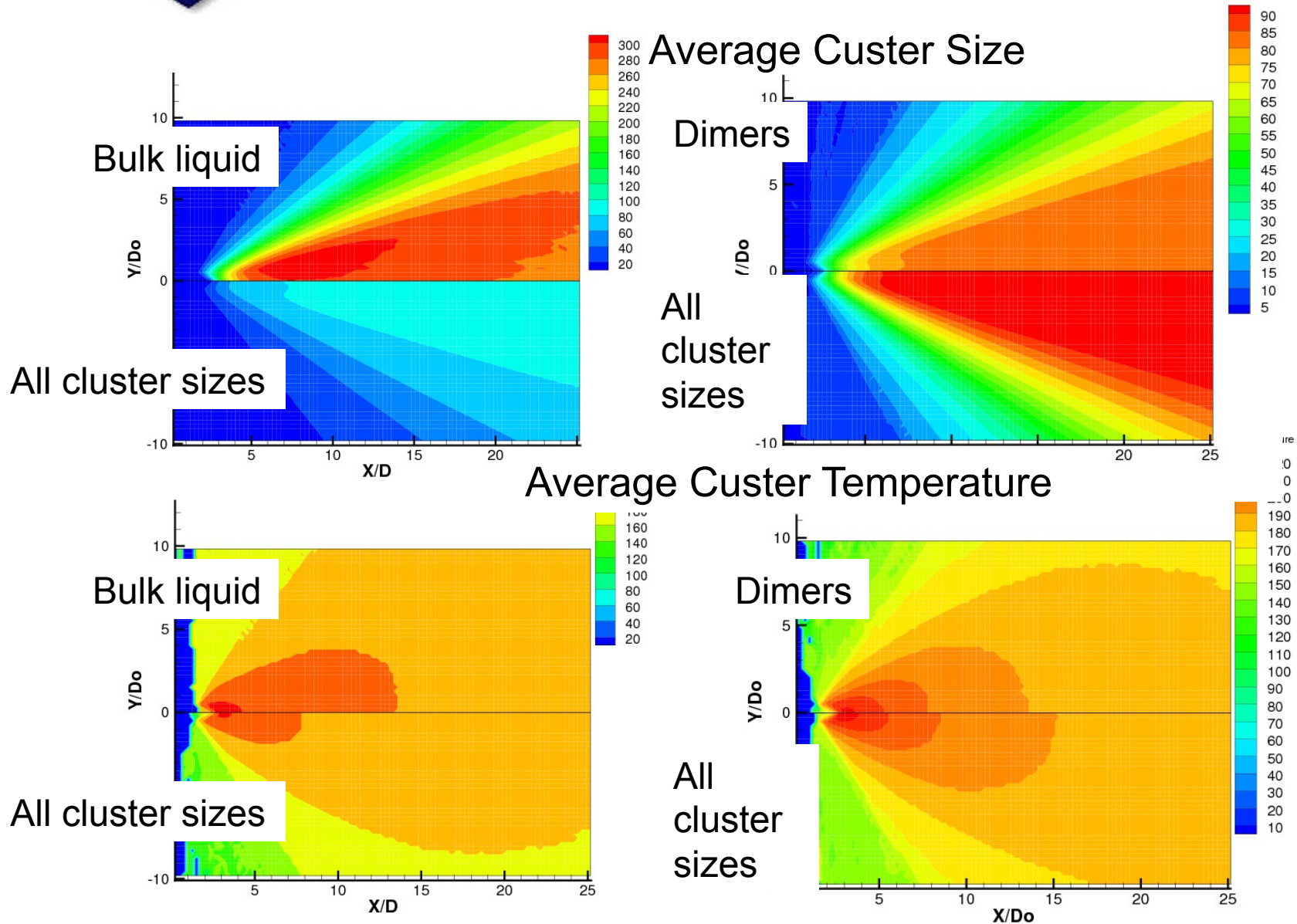


D. Levin – PRELIMINARY CEX 3-D Multi-step Results



- It is apparent that cross-species interaction results in a much complex plume structure than for a pure neutral flow. The energy exchange causes neutral species to achieve much higher speeds.
- The energy deposited by the ions into neutrals results in a lower expansion angle since directional velocity for neutrals are greatly increased when CEX reactions are present.

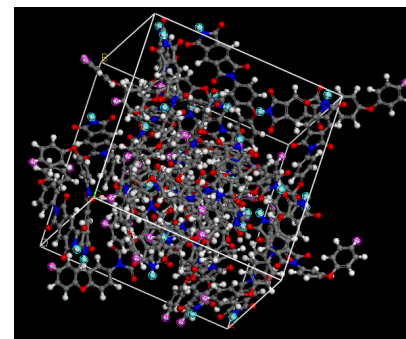
Sensitivity of DSMC Condensating Flows to Cluster Latent Heat Models



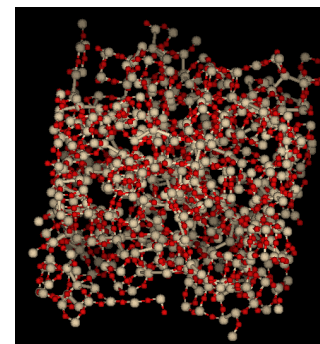
Simulations - A.C.T. Van Duin and A.Rahnamoun

- ReaxFF force field

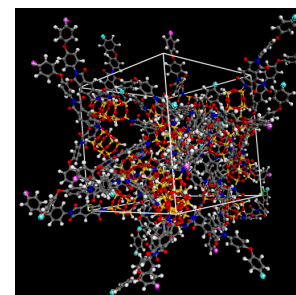
✓Kapton structure



✓Silica structure



✓POSS(Polyhedral Oligomeric Silsesquioxane) - Kapton structure
mixed with silica side-chains



ReaxFF Generated Sequence of Hypervelocity Surface Impact Events

✓ 8 ev bombardment energy

✓ Time step in the simulation is 0.1 fs

✓ Frequency of high energy oxygen addition is every 2000 iterations (2ps)

✓ Disintegration rate:
Kapton > POSS >> Silica

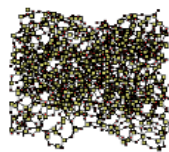
- POSS bombardment leads to silica clustering

- Main Kapton decomposition products: carbon monoxide and formaldehyde

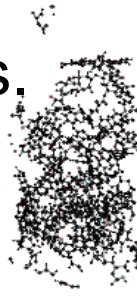
- Simulations can be used to define optimal silica addition to Kapton

- Ongoing simulations: water cluster bombardment of silica surfaces

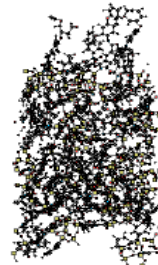
t=5 ps.



SiO structure

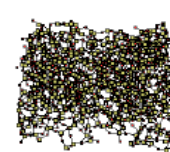


Kapton Structure

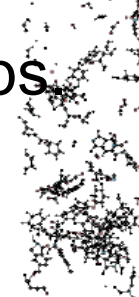


Kapton-POSS Structure

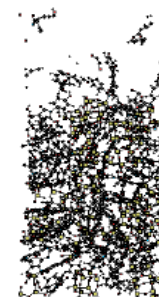
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SiO structure

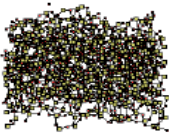


Kapton Structure

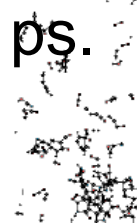


Kapton-POSS Structure

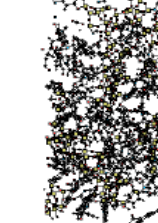
t=100 ps.



SiO structure

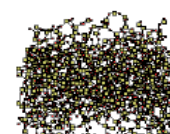


Kapton Structure



Kapton-POSS Structure

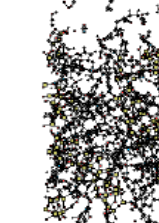
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SiO structure

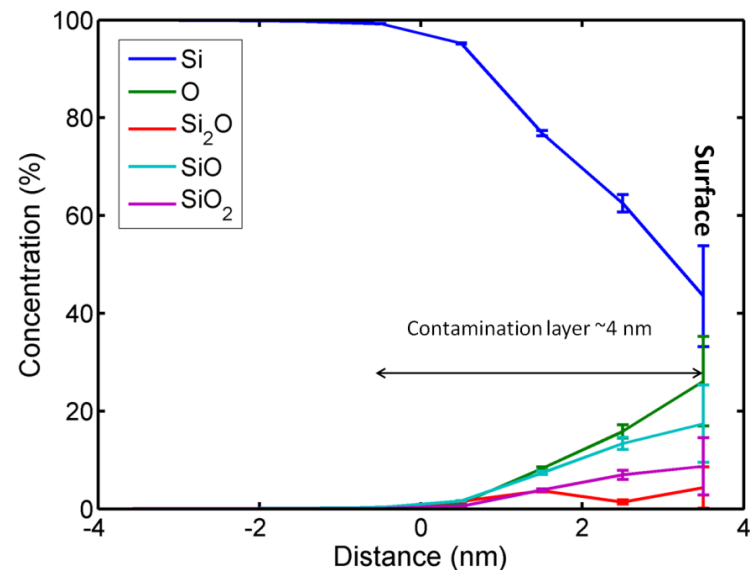
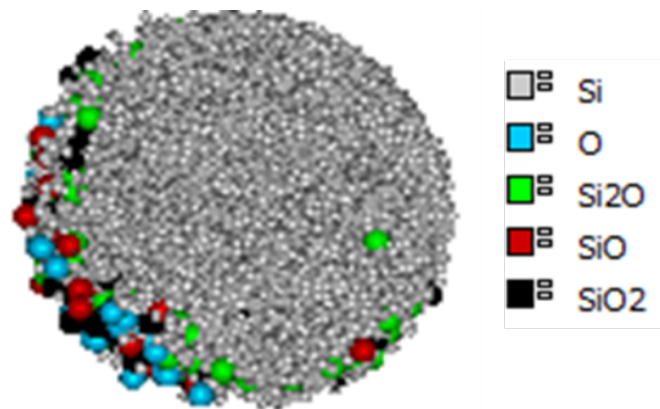


Kapton Structure



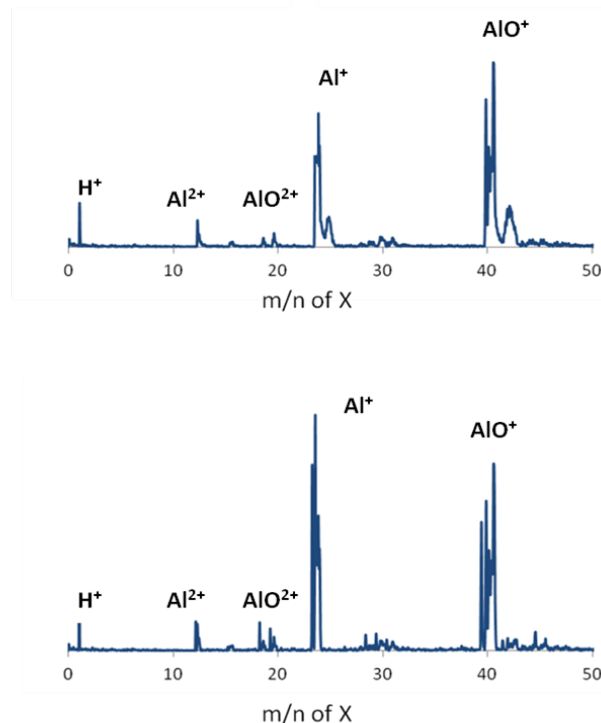
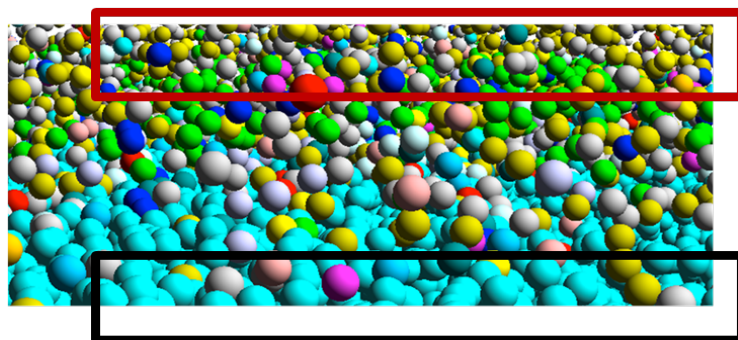
Kapton-POSS Structure

Atom probe tomography : Si / Silica/ Oxygen Reactions



- A cross section image of the specimen showing the degradation of silicon due to silicon-oxygen reaction at the surface was taken.
- The concentration profile across the Si-Oxide interface measuring surface chemistry and the diffusion of gas into the material was made.
- The ratio of O:Si-O compounds decreases with diffusion distance, implying that the metal-gas reactions and subsequent bond strengths are strongest at the metal-gas interface, while the resulting surface atoms are more weakly bonded to material.

Atom probe tomography: Al / Alumina/ Oxygen Reactions

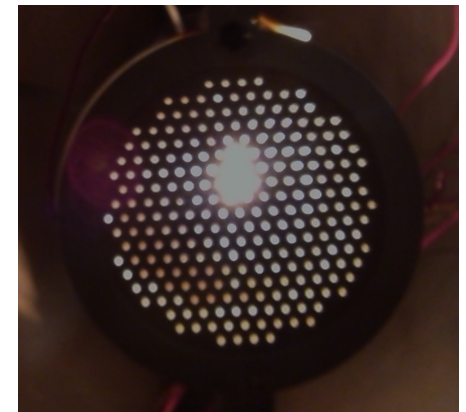
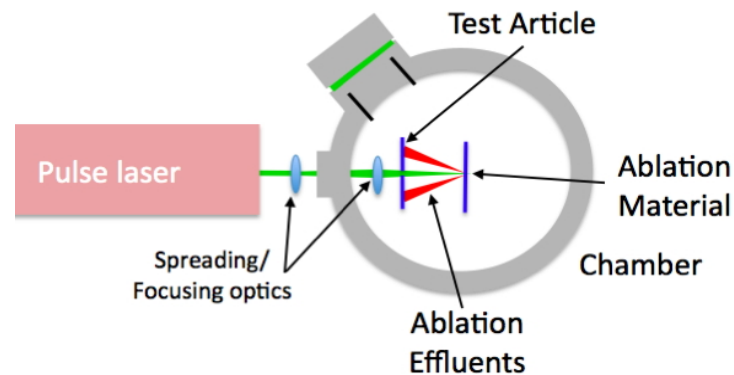
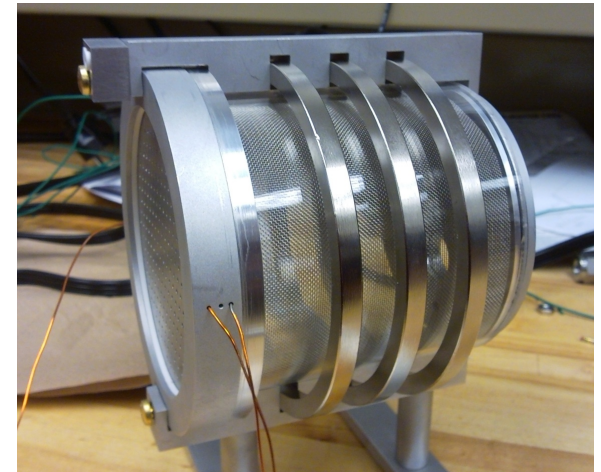


- Measurement of pair wise interactions between Al and other atoms / compounds at the atomic scale.
- The top spectra describes the compounds and corresponding valencies that degrade concurrent with Al^+ atom in the alumina region at the interface; the bottom spectra is the same except in the Al region near the interface.
- This map allows us to understand the complexity of the chemical states and identify the differences in bonding and inter-atomic interactions. The differences in the spectra represent changes in material degradation between phases at the metal surface, and describe the strength of inter-atomic interactions and mechanism for gas-solid reaction.

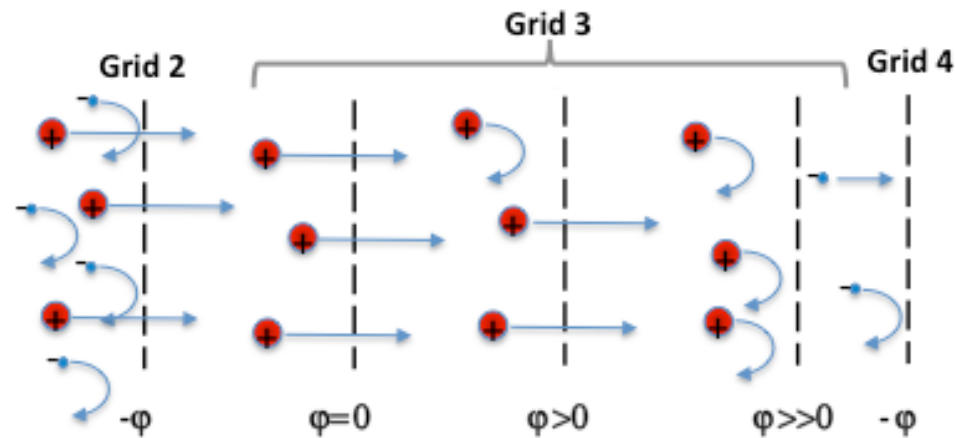
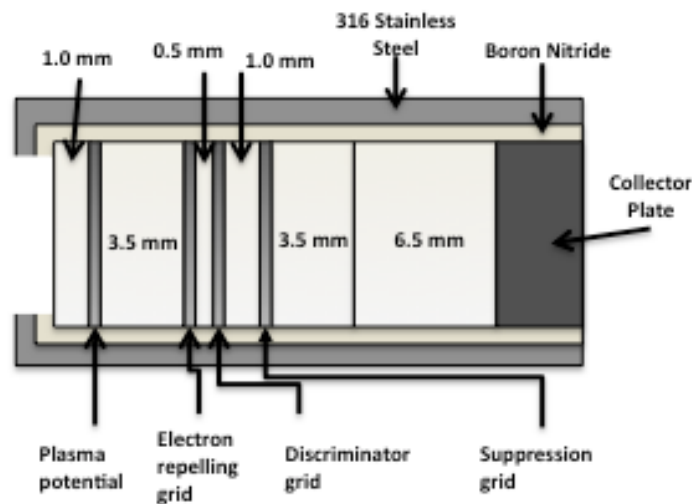
Material bombardment with well-characterized plasma state – Plasma Sources



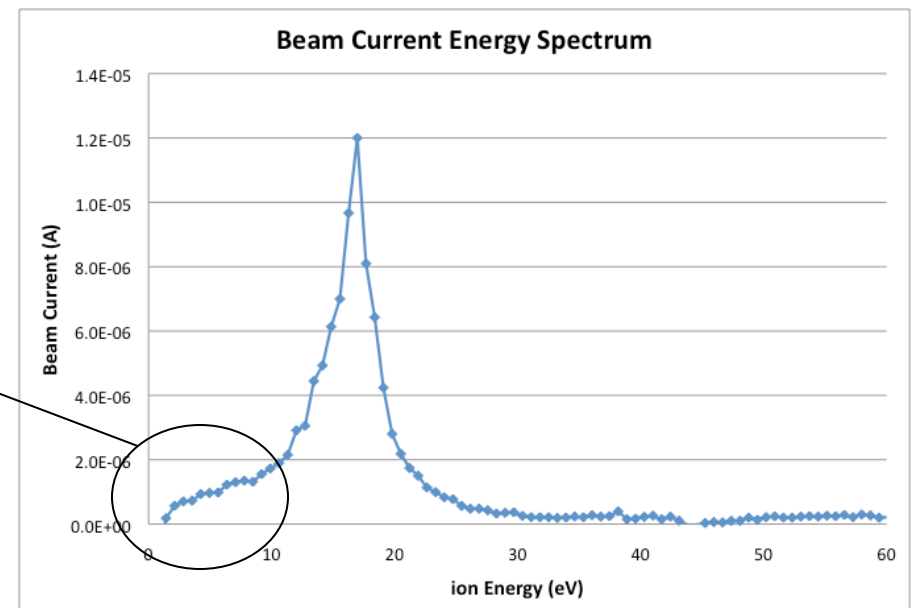
- Ion Engine Simulator – Completed, under test
 - Characteristic ion energy/density and neutral density
 - Also can be used for validation of CEX modeling
- Gen-II IonEtch sputter ion Gun – Available for testing
 - Microwave source supports reactive species
 - Energies up to 5 keV
- Dusty Plasma Source – Currently under design
 - AFOSR Funded DURIP
 - Will use laser ablation to generate both atoms and particulates/droplets from solids/liquids



Ion energy spectrum analysis – Retarding Potential Analyzer



- RPA used to determine beam energy spectrum
- Spatially resolving ion energy distribution can characterize CEX reactions
 - Lower energy ions appear farther from the exit plane and centerline
- For dusty plasma source, TOF will also be employed to determine charge-to-mass distribution as well





First Batch of Silicon tip coupons being shipped to UMD from Iowa State

- Each coupon contains 36 (6x6) individual pre-sharpened micro-tips
- Each tip is sharpened to a point less than 50 nm in diameter and is 100 microns (+/-20) in height
- Coupon are 3 mm x 7 mm and come on a gel pack

Prior to testing with coupons, small blanks will be used and analyzed with an SEM

- This will help to establish minimum and maximum exposure times for coupon testing

Coupons will be temporarily mounted to a backing plate during testing and then returned to the gel pack

